

IFW



Attorney Dkt. No. 54008.8033.US00
P03-0004

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: ERIC J. BERGMAN
APPLICATION No.: 10/631,376
FILED: JULY 30, 2003
FOR: **METHODS OF THINNING A SILICON WAFER
USING HF AND OZONE**

EXAMINER: Z. EL ARINI
ART UNIT: 1746
CONF. No: 2135

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed 01/12/2006, please amend the
Application as follows:

Amendments to the claims are reflected in the listing of claims which begins
on page 2 of this paper.

Remarks begin on page 5 of this paper.

[Continued on Next Page.]

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage in an envelope addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 29, 2006
Date of Deposit

Debbie Gilbert
Debbie Gilbert